



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 6774

SERIAL NUMBER 10/552,262	FILING OR 371(c) DATE 10/05/2005 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 33082M275
------------------------------------	---	---------------------	-------------------------------	---

APPLICANTS

Kazuhide Hasebe, Tokyo-To, JAPAN;
 Mitsuhiro Okada, Tokyo-To, JAPAN;
 Takashi Chiba, Tokyo-To, JAPAN;
 Jun Ogawa, Tokyo-To, JAPAN;

**** CONTINUING DATA *******

YFI

This application is a 371 of PCT/JP04/05643 04/20/2004

**** FOREIGN APPLICATIONS *******

YEIC

JAPAN 2003-117664 04/22/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

06/20/2006

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 2
Verified and Acknowledged	Examiner's Signature Initials				

ADDRESS

441

TITLE

Method for removing silicon oxide film and processing apparatus

FILING FEE RECEIVED 1410	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
------------------------------------	---	---